## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application No.	10/046,753
Filing Date	January 17, 2002
First Named Inventor	Koji Okamoto
Group Art Unit	3627
Examiner Name	Steven B. McAllister
Confirmation No.	2640
Attny. Dkt. No.	2922-181

Title of the Invention: SUPPLY SYSTEM OF COMPOUND FOR CHEMICAL VAPOR DEPOSITION AND THIN-FILM MANUFACTURING SYSTEM HAVING THE SAME COMPOUND SUPPLY SYSTEM

## AMENDMENT UNDER 37 C.F.R. §1.111

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Dear Sir:

In response to the Office Action mailed February 10, 2006, please enter the amendments and remarks contained on the following pages, which are summarized below. Applicant requests a two-month extension of time, which extends the original due date of May 10, 2006 to July 10, 2006.

**Amendments to the Claims** are reflected in the listing of claims which begin on page 2 of this paper.

**Amendments to the Drawings** begin on page 6 of this paper and include both an attached replacement sheet and an annotated sheet showing changes.

Remarks/Arguments begin on page 7 of this paper.

An **Appendix** including amended drawings figures is attached following page 9 of this paper.